Electronic Acknowledgement Receipt					
EFS ID:	3041299				
Application Number:	10540720				
International Application Number:					
Confirmation Number:	2419				
Title of Invention:	METHOD FOR MANUFACTURING SEMICONDUCTOR SUBSTRATE AND SEMICONDUCTOR SUBSTRATE				
First Named Inventor/Applicant Name:	Koichiro Kishima				
Correspondence Address:	William Frommer Frommer Lawrence & Haug 745 Fifth Avenue - New York NY 10151 US -				
Filer:	William S. Frommer/Fontella Mckenzie				
Filer Authorized By:	William S. Frommer				
Attorney Docket Number:	450101-04870.1				
Receipt Date:	24-MAR-2008				
Filing Date:	13-JAN-2006				
Time Stamp:	15:00:10				
Application Type:	U.S. National Stage under 35 USC 371				
Payment information:					
Submitted with Payment	yes				

Credit Card

\$1749

Payment Type

Payment was successfully received in RAM

RAM confirmation Number		225	225					
Deposit Acco	unt							
Authorized U	ser							
File Listing:								
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)			
			115311					

Warnings:

Information:

2	Fee Worksheet (PTO-06)	fee-info.pdf	8503	no	2
	, ,	'	Md3213451dc1014e1209dd5a88afd1fc 20866ad		

Warnings:

Information:

Total Files Size (in bytes):

123814

245c7481c2d2c1b3a62515d7b1b20114 9eb78618

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MFEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in the course

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.